

Sheet 1 of 1								INFORMATION DISCLOSURE STATEMENT			
FORM PTO 1449 (modified)				ATTY DOCKET NO. 2005_1513A		SERIAL NO. NEW 10/549849					
U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE				APPLICANT Jyun IWASHITA							
LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)				FILING DATE September 23, 2005				GROUP 1795			
Date Submitted to PTO: September 23, 2005				IC20 Rec'd PCT/PTO 23 SEP 2005							
U.S. PATENT DOCUMENTS											
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE				
/P.T.R./	AA	6,432,615	08/2002	Nakamura et al.	430	281.1	3/31/2000				
/P.T.R./	AB	6,395,453	05/2002	Kaneko et al.	430	281.1	2/28/2000				
/P.T.R./	AC	2001/0049073	12/2001	Hada et al.	430	270.1	5/29/2001				
/P.T.R./	AD	6,063,543	05/2000	Hien et al.	430	270.1	4/26/1999				
/P.T.R./	AE	6,306,990	10/2001	Hien et al.	562	272	4/26/1999				
	AF										
	AG										
FOREIGN PATENT DOCUMENTS											
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO				
/P.T.R./	AH	2001-247513	09/2001	JP			abstract				
/P.T.R./	AI	2001-166474	06/2001	JP			abstract				
/P.T.R./	AJ	2000-284473	10/2000	JP			corresponds to AA				
/P.T.R./	AK	2000-250204	09/2000	JP			corresponds to AB				
/P.T.R./	AL	2000-206694	07/2000	JP			corresponds to AC				
/P.T.R./	AM	2000-75486	03/2000	JP			corresponds to AD				
/P.T.R./	AN	2000-56459	02/2000	JP			abstract				
/P.T.R./	AO	2000-26548	01/2000	JP			corresponds to AE				
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)											
	AP										
	AQ										
EXAMINER /Ponder Thompson Rummel/					DATE CONSIDERED 10/15/2007						

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include cop. this form with next communication to applicant.

12/12/05

Sheet 1 of 1		INFORMATION DISCLOSURE STATEMENT								
FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) Date Submitted to PTO: December 12, 2005				ATTY DOCKET NO. 2005_1513A		SERIAL NO. 10/549,849				
				APPLICANT Jyun IWASHITA et al.						
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	AA									
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	AD									
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	AG									
	AH									
	AI									
FOREIGN PATENT DOCUMENTS										
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO			
/P.T.R./	AJ	8-3635	01/1996	JP			partial			
	AK									
	AL									
	AM									
	AN									
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)										
/P.T.R./	AO	Tsuchiya, Y. et al., "Investigation of Acid-Catalyzed Insolubilization Reactions for Alicyclic Polymers with Carboxyl Groups", <i>Journal of Photopolymer Science and Technology</i> , Vol. 10, No. 4, pp. 579 to 584 (1997).								
/P.T.R./	AP	Maeda, K. et al., "ArF Chemically Amplified Negative Resist Using Alicyclic Epoxy Polymer", <i>Journal of Photopolymer Science and Technology</i> , Vol. 11, No. 3, pp. 507 to 512 (1998).								
/P.T.R./	AQ	Iwasa, S. et al., "Novel negative photoresist based on polar alicyclic polymers for ArF excimer laser lithography", <i>SPIE</i> , Vol. 3333, pp. 417 to 424 (1998).								
EXAMINER				/Ponder Thompson Rummel/			DATE CONSIDERED			10/11/2007

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FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) <i>(Use several sheets if necessary)</i> Date Submitted to PTO: March 26, 2007				ATTY DOCKET NO. 2005_1513A APPLICANT Jyun IWASHITA et al FILING DATE December 12, 2005				SERIAL NO. 10/542,849 GROUP 1795	
U.S. PATENT DOCUMENTS									
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE		
/P.T.R./	AA	2002/0058197	5/2002	Nozaki et al.	430	270.1	8/24/2001		
/P.T.R./	AB	6,506,534	1/2003	Nozaki et al.	430	270.1	9/1/2000		
/P.T.R./	AC	2001/0003640	6/2001	Takechi et al.	430	270.1	12/19/2000		
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	AF								
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